

H2D2[®] LIGHT SOURCE UNIT

OVERVIEW

The H2D2 light source unit contains a high-brightness, high-end deuterium lamp (H2D2 lamp) that emits light at a brightness 6 times higher than our current deuterium lamps (L2D2 lamps). Despite its high brightness, the H2D2 is highly stable, has a long service life, and allows air-cooled operation by a specially designed housing. This feature makes it much more convenient and easy to use than ordinary water-cooled lamps.

The H2D2 can be used in various applications and enhances equipment sensitivity and throughput.



Left: Light source, Right: Power supply

TI SZF0047

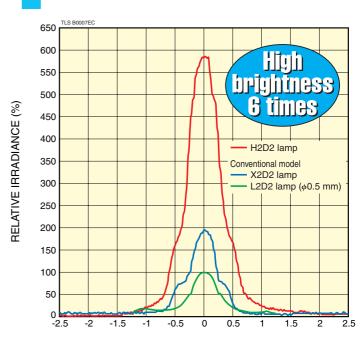
FEATURES

- High brightness: 6 times
 - (compared to conventional model)
- ●High stability: Fluctuation 0.05 %p-p (Max.)
 - **Drift** \pm **0.3** %h (Max.)
- **●Long Life: Warranty of 1000 hours**
- •Air cooling (needs no cooling water)
- External control
- Replaceable lamp

APPLICATIONS

- Semiconductor inspection
- •Film thickness measurement
- Electrostatic removal
- Photoionization
- Spectrophotometry
- Environmental measurement
- Optical component inspection

BRIGHTNESS DISTRIBUTION



DISTANCE FROM APERTURE CENTER (mm)

PACKAGE CONTENTS

| Type No. | Built-in lamp | Power supply | Light source to power supply cable | AC cable |
|----------|---------------|--------------|------------------------------------|----------|
| L11798 | ○(L12098) | \circ | 0 | \circ |
| L11799 | ○(L12099) | \circ | 0 | \circ |

SPECIFICATIONS

GENERAL RATINGS

| Parameter | L11798 | L11799 | Unit |
|----------------------------------|------------------------------|------------------|------|
| Spectral distribution | 115 to 400 160 to 400 | | nm |
| Window material | MgF ₂ | Synthetic silica | _ |
| Aperture size (arc point) | φ0.6 | | mm |
| Cooling method ^① | Fan cooling | | _ |
| Operating temperature range | +10 to +40 | | °C |
| Storage temperature range | 0 to +60 | | °C |
| Operating humidity range | Below 80 % (no condensation) | | _ |
| Storage humidity range | Below 85 % (no condensation) | | _ |
| Operation under vacuum condition | Possible | | |

•RECOMMENDED OPERATING CONDITIONS AND CHARACTERISTICS (at 25 °C)

| Parameter | | L11798 | L11799 | Unit |
|--------------------------------|--------------------------|--|--------|------|
| Warm-up time | | Approx. 30 | | S |
| Output stability | Fluctuation (p-p) (Max.) | 0.05 | | % |
| at 230 nm | Drift (Max.) | ±0.3 | | %/h |
| Light source guaranteed life 2 | | 1000 | | h |
| Input voltage (AC) | | 100 V to 240 V (100 V / 200 V auto switching), single phase 50 Hz to 60 Hz | | _ |
| Power consumption (Max.) | | 200 | | VA |

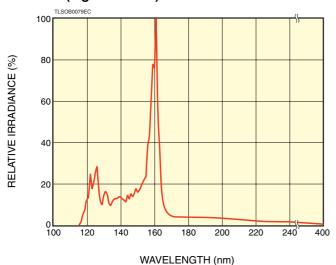
②End of life is defined as the time when light output at 230 nm falls below 50 % of its initial value.

● REPLACEMENT LAMP (sold separately)

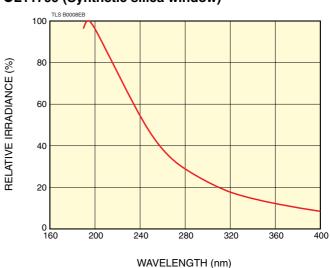
| Parameter | L12098 | L12099 | Unit |
|-----------------------|------------------|------------------|------|
| Spectral distribution | 115 to 400 | 160 to 400 | nm |
| Window material | MgF ₂ | Synthetic silica | _ |
| Light source | L11798 | L11799 - | |

SPECTRAL DISTRIBUTION

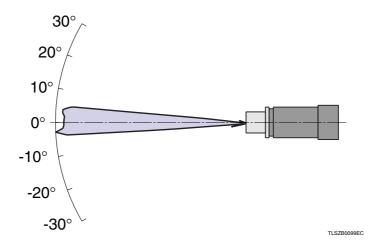
●L11798 (MgF₂ window)



●L11799 (Synthetic silica window)

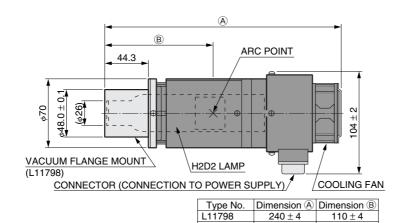


DIRECTIVITY (LIGHT DISTRIBUTION)



DIMENSIONAL OUTLINES (Unit: mm)

●LIGHT SOURCE (WEIGHT: Approx. 1.3 kg)

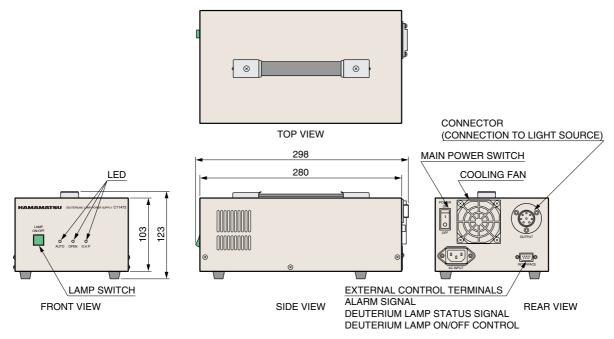


L11799

 215 ± 4

TLS A0007EA

●POWER SUPPLY (WEIGHT: Approx. 2.8 kg)



LIGHT SOURCE TO POWER SUPPLY CONNECTION CABLE LENGTH: 2000 $\pm\,50$

RELATED PRODUCTS

■VACUUM FLANGE

OVERVIEW

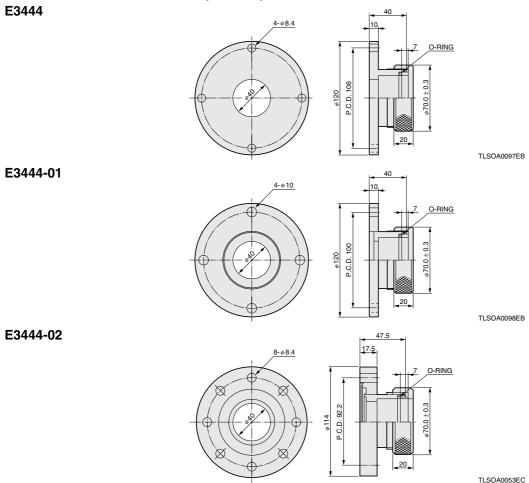
Various vacuum flanges are available for the H2D2 light source unit. The E3444-02 mounting flange meets ICF114 flange specifications and so easily attaches to ports of most vacuum equipment. We also provide other vacuum flanges including flanges made to JIS (Japanese Industrial Standards) specifications, so users can select the best flange that matches their vacuum vessel.

SPECIFICATIONS

| Parameter | E3444 | E3444-01 | E3444-02 |
|-------------------------|--|----------|----------|
| Sealing method | | O-ring | |
| Flange | Regular | JIS VF50 | ICF114 |
| Mounting flange | _ | JIS VG50 | ICF114 |
| Sealing force retention | 1.33 × 10 ⁻⁴ Pa L/s or less (1 × 10 ⁻⁶ Torr L/s) | | |

^{*} L11798 can be operated under vacuum condition. L11799 is not suitable for operation under vacuum condition.

●DIMENSIONAL OUTLINES (Unit: mm)



^{*} H2D2, L2D2 and X2D2 are the registed trademark of Hamamatsu Photonics K.K..

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